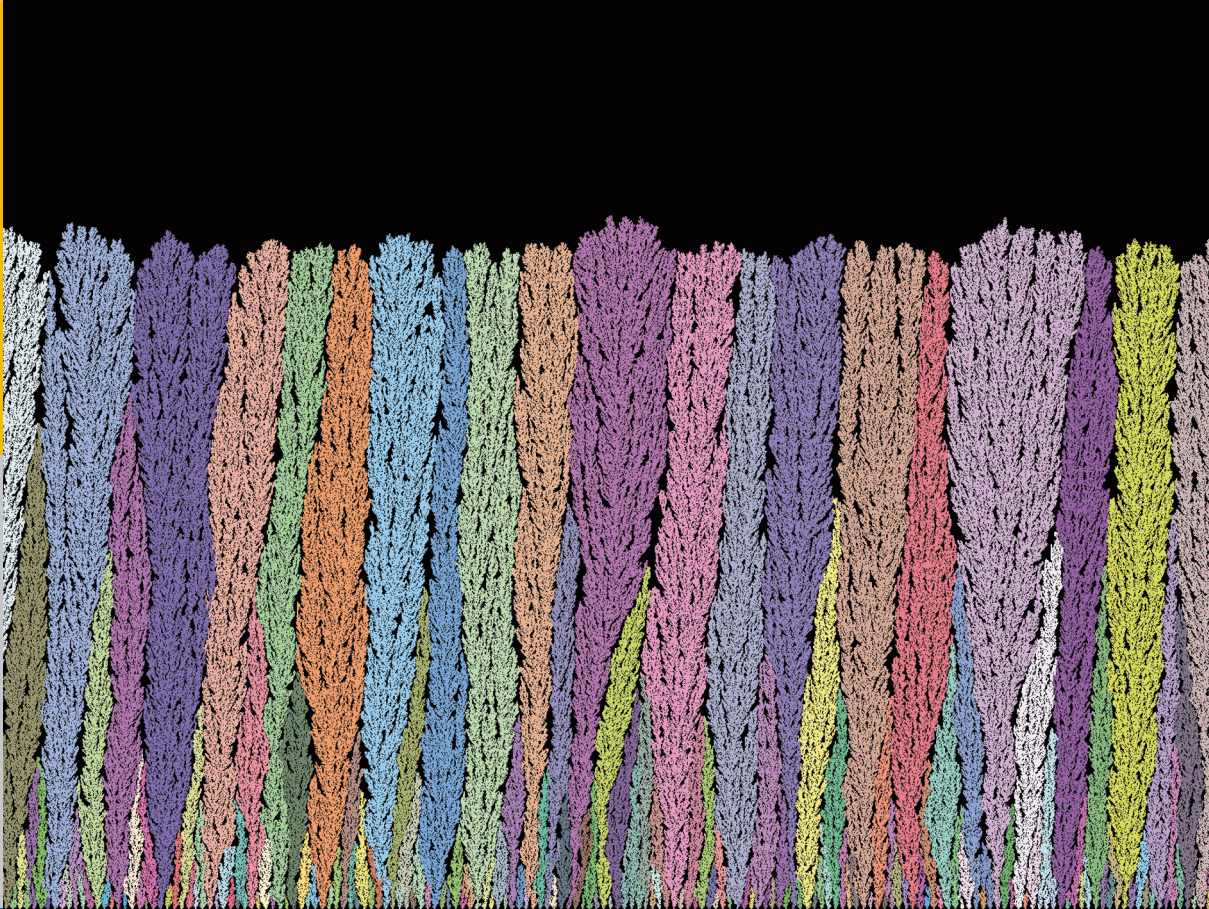


Numerical Simulation of Plasma Spray-Physical Vapor Deposition

Panpan Wang



Member of the Helmholtz Association

Energie & Umwelt /
Energy & Environment
Band / Volume 401
ISBN 978-3-95806-282-5

 **JÜLICH**
FORSCHUNGSZENTRUM

Forschungszentrum Jülich GmbH
Institute of Energy and Climate Research
Materials Synthesis and Processing (IEK-1)

Numerical Simulation of Plasma Spray-Physical Vapor Deposition

Panpan Wang

Schriften des Forschungszentrums Jülich
Reihe Energie & Umwelt / Energy & Environment

Band / Volume 401

ISSN 1866-1793

ISBN 978-3-95806-282-5

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